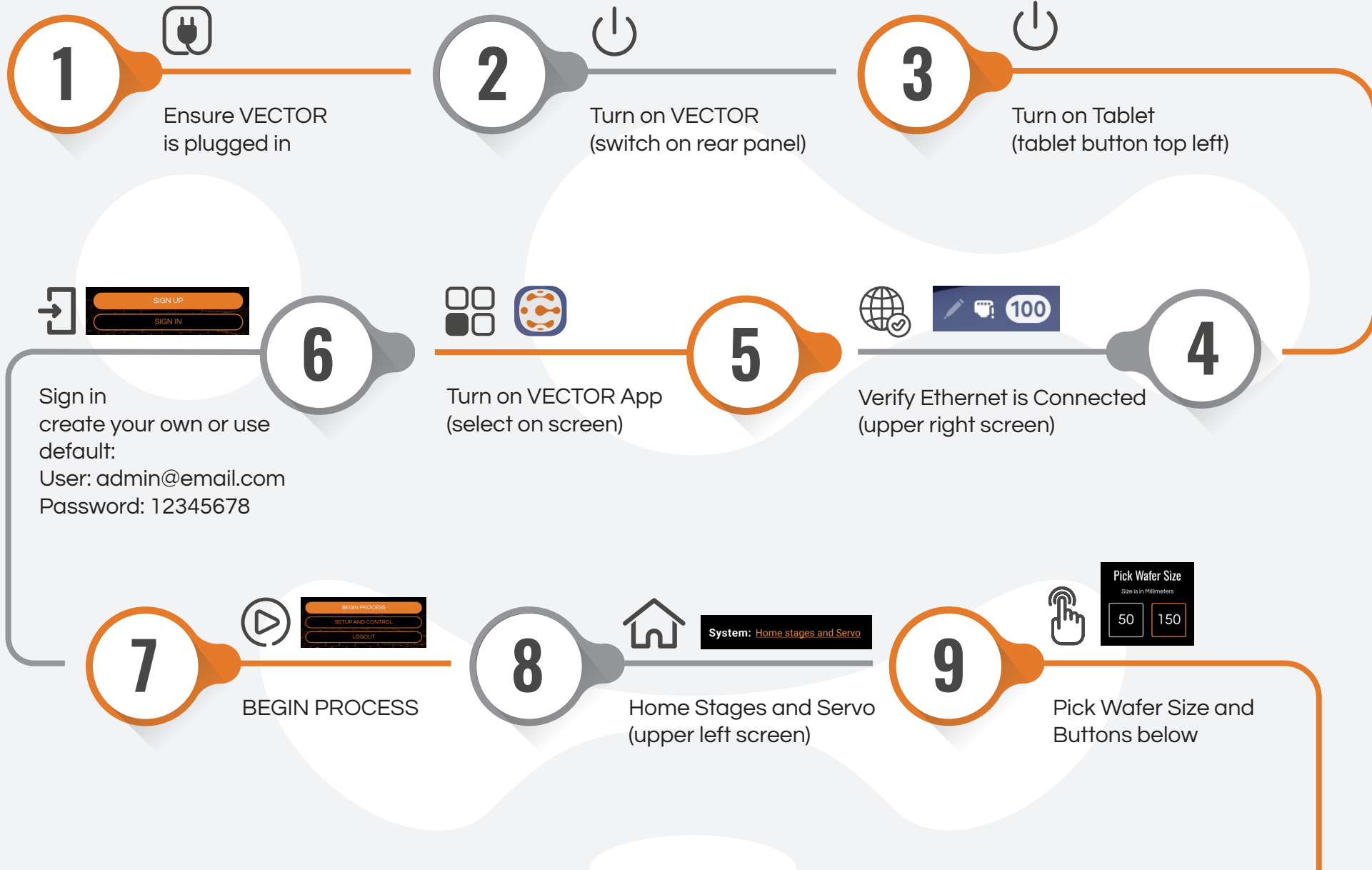


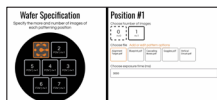


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QUICK START GUIDE





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Assign Image(s) to Wafer Positions

1. Select position
2. N=1 (to pattern) n=0 (to skip)
3. Select image
4. Define exposure time (3000 to start)
5. Repeat with remaining positions



11

Review,
then CONTINUE

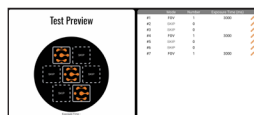


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Select Image(s) to Pattern

1. Select and hold until blue border illuminates
2. Select as many patterns as desired
3. Press "Select" at upper right

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Review Settings

Need to Edit?

use back arrow or pencil

Everything OK?

START PATTERNING

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Put on UV protective glasses

START PATTERNING

SCAN HERE TO WATCH INTRODUCTION TO VECTOR



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